



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10/643,680
Filing DateAugust 18, 2003
Confirmation No. 4607
Inventor.....Brenda D. Kraus et al.
AssigneeMicron Technology, Inc.
Group Art Unit 1762
Examiner Brian K. Talbot
Attorney's Docket No. MI22-2310
Customer No. 021567
Title: Atomic Layer Deposition Methods of Forming Conductive Metal Nitride
Comprising Layers

RESPONSE TO OCTOBER 12, 2006 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
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Responsive to the Office Action dated October 12, 2006, Applicant
amends and remarks as follows:

AMENDMENTS

01/16/2007 AWONDAF1 00000115 10643680

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